



TPW

PATENT
Customer No. 22,852
Attorney Docket No. 04329.3140

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Takashi YODA et al.) Group Art Unit: 2814
Application No.: 10/663,799) Examiner: Cao, Phat X.
Filed: September 17, 2003) Confirmation No. 3768
For: SEMICONDUCTOR DEVICE)
WITH POROUS LAYER AND)
CONDUCTIVE BARRIER LAYER)
(AS AMENDED))

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed January 11, 2005, the period for response to which extends through April 11, 2005, please amend the application as follows.

An Amendment to the Title is set forth on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims beginning on page 3 of this paper.

Remarks begin on page 9 of this paper.

AMENDMENT TO THE TITLE:

Please amend the title of this application as follows:

~~SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME~~
WITH POROUS LAYER AND CONDUCTIVE BARRIER LAYER